

Product Change Notice

(Notification - P1310065)

October 10, 2013

To: *Our Valued Customer (Name)*

Overview: The purpose of this notification is to communicate a product change of select Renesas Electronics America, Inc. (REA) devices. These devices are changing wafer fabrication sites. There is no part number change. Please see the "PCN Note" section for additional details.

Affected Products: A review of our shipment records to your company indicate the attached list of products is affected by this notification.

Booking Part Number	PCN Note
PN1	
PN2	
PN3	
PN4	

Part numbers given in this list are for active part numbers in REA database at the time of this notification.

Key Dates:

Final last time buy (LTB) orders for the affected part numbers from the current wafer fabrication site placed to REA or to a franchised REA distributor.	Jun. 16th, 2014
Planned date for last time shipment (LTS) from REA.	Dec 12th, 2014

Response: Please place last time buy (LTB) orders in a timely manner prior to the key dates listed to avoid product availability issues. If you anticipate volumes beyond your regular rate, please contact your REA sales representative with a forecast of your requirements. Shipments between the LTB and LTS dates are Non-Cancelable and Non-Returnable (NCNR).

You are encouraged to sample material from the new wafer fabrication site and begin qualification as soon as possible. Please contact you REA sales representative for sampling information.

Please contact your REA sales representative for any questions or comments.

Thank you for your attention.

Sincerely,

Renesas Electronics America, Inc.

Booking Part Number	Notes for PCN
RJK0451DPB-00#J5	Wafer Fabrication Site Change from Kofu to Saijyo
RJK0451DPB-WS#J5	Wafer Fabrication Site Change from Kofu to Saijyo
RJK0452DPB-00#J5	Wafer Fabrication Site Change from Kofu to Saijyo
RJK0452DPB-WS#J5	Wafer Fabrication Site Change from Kofu to Saijyo
RJK0453DPB-00#J5	Wafer Fabrication Site Change from Kofu to Saijyo
RJK0453DPB-WS#J5	Wafer Fabrication Site Change from Kofu to Saijyo
RJK0454DPB-00#J5	Wafer Fabrication Site Change from Kofu to Saijyo
RJK0454DPB-WS#J5	Wafer Fabrication Site Change from Kofu to Saijyo
RJK0601DPN-E0#T2	Wafer Fabrication Site Change from Kofu to Saijyo
RJK0602DPN-E0#T2	Wafer Fabrication Site Change from Kofu to Saijyo
RJK0603DPN-E0#T2	Wafer Fabrication Site Change from Kofu to Saijyo
RJK0653DPB-00#J5	Wafer Fabrication Site Change from Kofu to Saijyo
RJK0653DPB-WS#J5	Wafer Fabrication Site Change from Kofu to Saijyo
RJK0654DPB-00#J5	Wafer Fabrication Site Change from Kofu to Saijyo
RJK0654DPB-WS#J5	Wafer Fabrication Site Change from Kofu to Saijyo
RJK0657DPA-00#J5A	Wafer Fabrication Site Change from Kofu to Saijyo
RJK0658DPA-00#J5A	Wafer Fabrication Site Change from Kofu to Saijyo
RJK0658DPA-WS#J5A	Wafer Fabrication Site Change from Kofu to Saijyo
RJK0659DPA-00#J5A	Wafer Fabrication Site Change from Kofu to Saijyo
RJK0660DPA-00#J5A	Wafer Fabrication Site Change from Kofu to Saijyo
RJK0660DPA-WS#J5A	Wafer Fabrication Site Change from Kofu to Saijyo
RJK0701DPN-E0#T2	Wafer Fabrication Site Change from Kofu to Saijyo
RJK0701DPP-E0#T2	Wafer Fabrication Site Change from Kofu to Saijyo
RJK0702DPN-E0#T2	Wafer Fabrication Site Change from Kofu to Saijyo
RJK0702DPP-E0#T2	Wafer Fabrication Site Change from Kofu to Saijyo
RJK0703DPN-E0#T2	Wafer Fabrication Site Change from Kofu to Saijyo
RJK0703DPP-E0#T2	Wafer Fabrication Site Change from Kofu to Saijyo
RJK0851DPB-00#J5	Wafer Fabrication Site Change from Kofu to Saijyo
RJK0851DPB-WS#J5	Wafer Fabrication Site Change from Kofu to Saijyo
RJK0852DPB-00#J5	Wafer Fabrication Site Change from Kofu to Saijyo
RJK0852DPB-WS#J5	Wafer Fabrication Site Change from Kofu to Saijyo
RJK0854DPB-00#J5	Wafer Fabrication Site Change from Kofu to Saijyo
RJK0854DPB-WS#J5	Wafer Fabrication Site Change from Kofu to Saijyo
RJK0856DPB-00#J5	Wafer Fabrication Site Change from Kofu to Saijyo
RJK0856DPB-WS#J5	Wafer Fabrication Site Change from Kofu to Saijyo
RJK1001DPN-E0#T2	Wafer Fabrication Site Change from Kofu to Saijyo
RJK1001DPP-E0#T2	Wafer Fabrication Site Change from Kofu to Saijyo
RJK1002DPN-E0#T2	Wafer Fabrication Site Change from Kofu to Saijyo
RJK1002DPP-E0#T2	Wafer Fabrication Site Change from Kofu to Saijyo
RJK1003DPP-E0#T2	Wafer Fabrication Site Change from Kofu to Saijyo
RJK1028DNS-00#J5	Wafer Fabrication Site Change from Kofu to Saijyo
RJK1051DPB-00#J5	Wafer Fabrication Site Change from Kofu to Saijyo
RJK1051DPB-WS#J5	Wafer Fabrication Site Change from Kofu to Saijyo
RJK1052DPB-00#J5	Wafer Fabrication Site Change from Kofu to Saijyo
RJK1052DPB-WS#J5	Wafer Fabrication Site Change from Kofu to Saijyo
RJK1053DPB-00#J5	Wafer Fabrication Site Change from Kofu to Saijyo

RJK1053DPB-WS#J5	Wafer Fabrication Site Change from Kofu to Saijyo
RJK1055DPB-00#J5	Wafer Fabrication Site Change from Kofu to Saijyo
RJK1055DPB-WS#J5	Wafer Fabrication Site Change from Kofu to Saijyo
R1EV24004ASAS0I#K0	Wafer Fabrication Site Change from Kofu to Naka
R2A30444BZ#W0	Wafer Fabrication Site Change from Kofu to GFT
2SA1611(0)-T1-A	Wafer Fabrication Site Change from Tsuruoka to Naka
2SA1611(0)-T2-A	Wafer Fabrication Site Change from Tsuruoka to Naka
2SA1611-D-T1-A	Wafer Fabrication Site Change from Tsuruoka to Naka
2SA1611-T1-A	Wafer Fabrication Site Change from Tsuruoka to Naka
2SA1611-T2-A	Wafer Fabrication Site Change from Tsuruoka to Naka
2SA1612-T1-A	Wafer Fabrication Site Change from Tsuruoka to Naka
2SA1836-T1-A	Wafer Fabrication Site Change from Tsuruoka to Naka
2SA1871-T1-AZ	Wafer Fabrication Site Change from Shiga to Naka
2SA812-D-T2-A	Wafer Fabrication Site Change from Tsuruoka to Naka
2SA812-T1B-A	Wafer Fabrication Site Change from Tsuruoka to Naka
2SA812-T2B-A	Wafer Fabrication Site Change from Tsuruoka to Naka
2SB1301-T1-AZ	Wafer Fabrication Site Change from Tsuruoka to Naka
2SB1453(1)-S6-AZ	Wafer Fabrication Site Change from Shiga to Naka
2SB1475-T1-A	Wafer Fabrication Site Change from Tsuruoka to Naka
2SB624-T1B-A	Wafer Fabrication Site Change from Tsuruoka to Naka
2SB768-E1-AZ	Wafer Fabrication Site Change from Shiga to Naka
2SB768-E2-AZ	Wafer Fabrication Site Change from Shiga to Naka
2SC1623(0)-T1B-A	Wafer Fabrication Site Change from Tsuruoka to Naka
2SC1623-D-T1-A	Wafer Fabrication Site Change from Tsuruoka to Naka
2SC1623-T1B-A	Wafer Fabrication Site Change from Tsuruoka to Naka
2SC1623-T2B-A	Wafer Fabrication Site Change from Tsuruoka to Naka
2SC1654-T1B-A	Wafer Fabrication Site Change from Tsuruoka to Naka
2SC2780-T1-AZ	Wafer Fabrication Site Change from Tsuruoka to Naka
2SC3554-T1-AZ	Wafer Fabrication Site Change from Tsuruoka to Naka
2SC4173-T1-A	Wafer Fabrication Site Change from Tsuruoka to Naka
2SC4177(0)-T1-A	Wafer Fabrication Site Change from Tsuruoka to Naka
2SC4177-D-T1-A	Wafer Fabrication Site Change from Tsuruoka to Naka
2SC4177-D-T2-A	Wafer Fabrication Site Change from Tsuruoka to Naka
2SC4177-T1-A	Wafer Fabrication Site Change from Tsuruoka to Naka
2SC4178-T1-A	Wafer Fabrication Site Change from Tsuruoka to Naka
2SC4179-T1-A	Wafer Fabrication Site Change from Tsuruoka to Naka
2SC4180-T1-A	Wafer Fabrication Site Change from Tsuruoka to Naka
2SC4181A-T1-A	Wafer Fabrication Site Change from Tsuruoka to Naka
2SC4181-T1-A	Wafer Fabrication Site Change from Tsuruoka to Naka
2SC4783-T1-A	Wafer Fabrication Site Change from Tsuruoka to Naka
2SC4942-T1-AZ	Wafer Fabrication Site Change from Tsuruoka to Naka
2SD1615A-T2-AZ	Wafer Fabrication Site Change from Tsuruoka to Naka
2SD2165-AZ	Wafer Fabrication Site Change from Shiga to Naka
2SD2425-T1-AZ	Wafer Fabrication Site Change from Tsuruoka to Naka
2SD596-T1B-A	Wafer Fabrication Site Change from Tsuruoka to Naka
2SD999-T1-AZ	Wafer Fabrication Site Change from Tsuruoka to Naka
2SJ557A-T1B-AT	Wafer Fabrication Site Change from Shiga to Kawashiri

2SJ599-ZK-E1-AY	Wafer Fabrication Site Change from Shiga to Kawashiri
2SJ621-T1B-A	Wafer Fabrication Site Change from Shiga to Kawashiri
2SJ621-T1B-AT	Wafer Fabrication Site Change from Shiga to Kawashiri
2SJ624-T1B-A	Wafer Fabrication Site Change from Shiga to Kawashiri
2SJ624-T1B-AT	Wafer Fabrication Site Change from Shiga to Kawashiri
2SJ673-AZ	Wafer Fabrication Site Change from Shiga to Kawashiri
2SJ687-ZK-E1-AY	Wafer Fabrication Site Change from Shiga to Kawashiri
2SJ690-T1B-AT	Wafer Fabrication Site Change from Shiga to Kawashiri
2SK3353-AZ	Wafer Fabrication Site Change from Shiga to Kawashiri
2SK3366-Z-E1-AZ	Wafer Fabrication Site Change from Shiga to Kawashiri
2SK3367(01)-Z-E1-AZ	Wafer Fabrication Site Change from Shiga to Kawashiri
2SK3386(0)-Z-E1-AZ	Wafer Fabrication Site Change from Shiga to Kawashiri
2SK3386-Z-E1-AZ	Wafer Fabrication Site Change from Shiga to Kawashiri
2SK3408-T1B-AT	Wafer Fabrication Site Change from Shiga to Kawashiri
2SK3430-AZ	Wafer Fabrication Site Change from Shiga to Kawashiri
2SK3431-AZ	Wafer Fabrication Site Change from Shiga to Kawashiri
2SK3481-AZ	Wafer Fabrication Site Change from Shiga to Kawashiri
2SK3576-T1B-A	Wafer Fabrication Site Change from Shiga to Kawashiri
2SK3576-T1B-AT	Wafer Fabrication Site Change from Shiga to Kawashiri
2SK3755-AZ	Wafer Fabrication Site Change from Shiga to Kawashiri
2SK3793-AZ	Wafer Fabrication Site Change from Shiga to Kawashiri
2SK3811-ZP-E1-AY	Wafer Fabrication Site Change from Shiga to Kawashiri
2SK3812-ZP-E2-AY	Wafer Fabrication Site Change from Shiga to Kawashiri
2SK3813(0)-Z-E1-AZ	Wafer Fabrication Site Change from Shiga to Naka(Kawashiri)
2SK3813-AZ	Wafer Fabrication Site Change; Shiga to Naka(Kawashiri)
2SK3813-Z-E1-AZ	Wafer Fabrication Site Change from Shiga to Naka(Kawashiri)
2SK4035-T1B-A	Wafer Fabrication Site Change from Shiga to Kawashiri
2SK4035-T1B-AT	Wafer Fabrication Site Change from Shiga to Kawashiri
2SK4079(1)-T1B-AT	Wafer Fabrication Site Change from Shiga to Kawashiri
2SK4144(01)-S6-AZ	Wafer Fabrication Site Change from Shiga to Kawashiri
2SK4147-T1B-AT	Wafer Fabrication Site Change from Shiga to Kawashiri
CE2F3P-T-AZ	Wafer Fabrication Site Change from Tsuruoka to Naka
FA1A4M(0)-T2B-A	Wafer Fabrication Site Change from Tsuruoka to Naka
FA1A4M-D-T1-A	Wafer Fabrication Site Change from Tsuruoka to Naka
FA1A4P-T1B-A	Wafer Fabrication Site Change from Tsuruoka to Naka
FA1A4P-T2B-A	Wafer Fabrication Site Change from Tsuruoka to Naka
FA1F4M-T1B-A	Wafer Fabrication Site Change from Tsuruoka to Naka
FA1L3M-T1B-A	Wafer Fabrication Site Change from Tsuruoka to Naka
FA1L3M-T2B-A	Wafer Fabrication Site Change from Tsuruoka to Naka
FA1L3N(0)-T1B-A	Wafer Fabrication Site Change from Tsuruoka to Naka
FA1L4M-T2B-A	Wafer Fabrication Site Change from Tsuruoka to Naka
FA4A3Q-T1B-A	Wafer Fabrication Site Change from Tsuruoka to Naka
FA4A4P(0)-T1B-A	Wafer Fabrication Site Change from Tsuruoka to Naka
FA4F4M-T1B-A	Wafer Fabrication Site Change from Tsuruoka to Naka
FN1A3Q-T2B-A	Wafer Fabrication Site Change from Tsuruoka to Naka
FN1A4M-T1B-A	Wafer Fabrication Site Change from Tsuruoka to Naka
FN1A4M-T2B-A	Wafer Fabrication Site Change from Tsuruoka to Naka

FN1F4M-T2B-A	Wafer Fabrication Site Change from Tsuruoka to Naka
FN1L4M-T2B-A	Wafer Fabrication Site Change from Tsuruoka to Naka
FN4L4M-T1B-A	Wafer Fabrication Site Change from Tsuruoka to Naka
GA1A4M(0)-T2-A	Wafer Fabrication Site Change from Tsuruoka to Naka
GA1L4M-T2-A	Wafer Fabrication Site Change from Tsuruoka to Naka
GN1A4M-T2-A	Wafer Fabrication Site Change from Tsuruoka to Naka
GN1L4M-T2-A	Wafer Fabrication Site Change from Tsuruoka to Naka
HE1A4A-D-T2-AZ	Wafer Fabrication Site Change from Tsuruoka to Naka
KA4A4M(0)-T1-AT	Wafer Fabrication Site Change from Tsuruoka to Naka
KA4F3R(0)-T1-A	Wafer Fabrication Site Change from Tsuruoka to Naka
KA4L4M(0)-T1-A	Wafer Fabrication Site Change from Tsuruoka to Naka
KN4A4M(0)-T1-A	Wafer Fabrication Site Change from Tsuruoka to Naka
N0100P-T1-AT	Wafer Fabrication Site Change from Shiga to Kawashiri
N0300N-T1B-AT	Wafer Fabrication Site Change from Shiga to Kawashiri
N0300P-T1B-AT	Wafer Fabrication Site Change from Shiga to Kawashiri
N0301P-T1-AT	Wafer Fabrication Site Change from Shiga to Kawashiri
N0302P-T1-AT	Wafer Fabrication Site Change from Shiga to Kawashiri
N2500N-T1B-AT	Wafer Fabrication Site Change from Shiga to Kawashiri
NP100P06PLG-E1-AY	Wafer Fabrication Site Change from Shiga to Naka(Kawashiri)
NP100P06PLG-E2-AY	Wafer Fabrication Site Change from Shiga to Naka(Kawashiri)
NP109N04PUJ-E1B-AY	Wafer Fabrication Site Change from Shiga to Kawashiri
NP109N04PUJ-E2B-AY	Wafer Fabrication Site Change from Shiga to Kawashiri
NP109N055PUJ-E1B-AY	Wafer Fabrication Site Change from Shiga to Kawashiri
NP109N055PUJ-E2B-AY	Wafer Fabrication Site Change from Shiga to Kawashiri
NP110N03PUG-E1-AZ	Wafer Fabrication Site Change from Shiga to Naka(Kawashiri)
NP110N055PUG-E1-AY	Wafer Fabrication Site Change from Shiga to Naka(Kawashiri)
NP110N055PUG-E1-AZ	Wafer Fabrication Site Change from Shiga to Naka(Kawashiri)
NP110N055PUG-E2-AY	Wafer Fabrication Site Change from Shiga to Naka(Kawashiri)
NP110N055PUJ-E1B-AY	Wafer Fabrication Site Change from Shiga to Kawashiri
NP110N055PUJ-E2B-AY	Wafer Fabrication Site Change from Shiga to Kawashiri
NP160N04TDG-E2-AY	Wafer Fabrication Site Change from Shiga to Naka(Kawashiri)
NP160N04TUJ-E1-AY	Wafer Fabrication Site Change from Shiga to Kawashiri
NP160N04TUJ-E2-AY	Wafer Fabrication Site Change from Shiga to Kawashiri
NP160N055TUJ-E1-AY	Wafer Fabrication Site Change from Shiga to Kawashiri
NP160N055TUJ-E2-AY	Wafer Fabrication Site Change from Shiga to Kawashiri
NP180N04TUG-E1-AY	Wafer Fabrication Site Change from Shiga to Naka(Kawashiri)
NP180N04TUG-E2-AY	Wafer Fabrication Site Change from Shiga to Naka
NP180N04TUJ-E1-AY	Wafer Fabrication Site Change from Shiga to Kawashiri
NP180N04TUJ-E2-AY	Wafer Fabrication Site Change from Shiga to Kawashiri
NP180N055TUJ-E1-AY	Wafer Fabrication Site Change from Shiga to Kawashiri
NP180N055TUJ-E2-AY	Wafer Fabrication Site Change from Shiga to Kawashiri
NP22N055SHE-E1-AY	Wafer Fabrication Site Change from Shiga to Kawashiri
NP30N04QUK(1)-E1-AY#YC	Wafer Fabrication Site Change; Shiga to Naka(Kawashiri)
NP32N055SDE-E1-AZ	Wafer Fabrication Site Change from Shiga to Kawashiri
NP36P04KDG-E1-AY	Wafer Fabrication Site Change from Shiga to Naka
NP36P04KDG-E2-AY	Wafer Fabrication Site Change from Shiga to Naka
NP48N055KHE-E1-AY	Wafer Fabrication Site Change from Shiga to Kawashiri

NP48N055ZHE(1)W-U	Wafer Fabrication Site Change from Shiga to Kawashiri
NP48N055ZLE(1)W-U	Wafer Fabrication Site Change from Shiga to Kawashiri
NP50P04KDG-E1-AY	Wafer Fabrication Site Change from Shiga to Naka
NP50P04KDG-E2-AY	Wafer Fabrication Site Change from Shiga to Naka
NP55N03SUG-E1-AY	Wafer Fabrication Site Change; Shiga to Naka(Kawashiri)
NP55N04SUG-E1-AY	Wafer Fabrication Site Change from Shiga to Naka
NP55N04SUG-E1-AZ	Wafer Fabrication Site Change from Shiga to Naka
NP55N055SDG-E1-AY	Wafer Fabrication Site Change; Shiga to Naka(Kawashiri)
NP55N055SUG(1)-E1-AY	Wafer Fabrication Site Change from Shiga to Naka
NP55N055SUG-E1-AY	Wafer Fabrication Site Change from Shiga to Naka
NP55N055SUG-E1-AZ	Wafer Fabrication Site Change from Shiga to Naka
NP60N03KUG-E1-AY	Wafer Fabrication Site Change; Shiga to Naka(Kawashiri)
NP60N03KUG-E1-AZ	Wafer Fabrication Site Change; Shiga to Naka(Kawashiri)
NP60N03SUG(1)-E1-AY	Wafer Fabrication Site Change from Shiga to Naka
NP60N03SUG-E1-AY	Wafer Fabrication Site Change from Shiga to Naka
NP60N04KUG-E1-AZ	Wafer Fabrication Site Change; Shiga to Naka(Kawashiri)
NP60N04KUG-E2-AY	Wafer Fabrication Site Change; Shiga to Naka(Kawashiri)
NP60N04MUG-S18-AY	Wafer Fabrication Site Change; Shiga to Naka(Kawashiri)
NP80N04KHE-E1-AY	Wafer Fabrication Site Change from Shiga to Kawashiri
NP80N04PLG-E1B-AY	Wafer Fabrication Site Change from Shiga to Naka
NP80N04PLG-E2B-AY	Wafer Fabrication Site Change from Shiga to Naka
NP80N04PUG-E1B-AY	Wafer Fabrication Site Change from Shiga to Naka
NP80N04PUG-E2B-AY	Wafer Fabrication Site Change from Shiga to Naka
NP80N055KLE-E1-AY	Wafer Fabrication Site Change from Shiga to Kawashiri
NP80N055KLE-E2-AY	Wafer Fabrication Site Change from Shiga to Kawashiri
NP80N055MHE-S18-AY	Wafer Fabrication Site Change from Shiga to Kawashiri
NP80N06MLG-S18-AY	Wafer Fabrication Site Change from Shiga to Naka
NP80N06PLG-E1B-AY	Wafer Fabrication Site Change; Shiga to Naka(Kawashiri)
NP82N03PUG-E1-AY	Wafer Fabrication Site Change; Shiga to Naka(Kawashiri)
NP82N03PUG-E1-AZ	Wafer Fabrication Site Change; Shiga to Naka(Kawashiri)
NP82N03PUG-E2-AY	Wafer Fabrication Site Change; Shiga to Naka(Kawashiri)
NP82N03PUG-E2-AZ	Wafer Fabrication Site Change; Shiga to Naka(Kawashiri)
NP82N04NUG-S18-AY	Wafer Fabrication Site Change from Shiga to Naka
NP82N04PDG-E1-AY	Wafer Fabrication Site Change; Shiga to Naka(Kawashiri)
NP82N04PDG-E2-AY	Wafer Fabrication Site Change; Shiga to Naka(Kawashiri)
NP82N06PDG-E2-AY	Wafer Fabrication Site Change from Shiga to Naka
NP82N10PUF-E1-AY	Wafer Fabrication Site Change from Shiga to Kawashiri
NP83P06PDG-E1-AY	Wafer Fabrication Site Change from Shiga to Naka
NP83P06PDG-E2-AY	Wafer Fabrication Site Change from Shiga to Naka
NP84N075KUE-E1-AY	Wafer Fabrication Site Change from Shiga to Kawashiri
NP88N03KDG-E1-AY	Wafer Fabrication Site Change; Shiga to Naka(Kawashiri)
NP88N04KUG-E1-AY	Wafer Fabrication Site Change; Shiga to Naka(Kawashiri)
NP88N04KUG-E1-AZ	Wafer Fabrication Site Change; Shiga to Naka(Kawashiri)
NP88N04KUG-E2-AY	Wafer Fabrication Site Change; Shiga to Naka(Kawashiri)
NP88N04NUG-S18-AY	Wafer Fabrication Site Change; Shiga to Naka(Kawashiri)
NP88N055KUG-E1-AZ	Wafer Fabrication Site Change; Shiga to Naka(Kawashiri)
NP88N075KUE-E1-AY	Wafer Fabrication Site Change from Shiga to Kawashiri

NP88N075KUE-E2-AY	Wafer Fabrication Site Change from Shiga to Kawashiri
NP88N075MUE-S18-AY	Wafer Fabrication Site Change from Shiga to Kawashiri
NP90N03VLG-E1-AY	Wafer Fabrication Site Change from Shiga to Naka
NP90N04MUG-S18-AY	Wafer Fabrication Site Change from Shiga to Naka
NP90N04VUG-E1-AY	Wafer Fabrication Site Change; Shiga to Naka(Kawashiri)
NP90N04VUG-E2-AY	Wafer Fabrication Site Change; Shiga to Naka(Kawashiri)
NP90N06VLG-E1-AY	Wafer Fabrication Site Change from Shiga to Naka
UPA1727G-E1-A	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1727G-E1-AT	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1760G-E1-AT	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1763G(0)-E2-AT	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1763G-E1-A	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1763G-E2-A	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1764G-E1-AT	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1770G-E1-A	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1770G-E1-AT	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1803GR-9JG-E1-A	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1804GR-9JG-E1-A	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1809GR-9JG-E1-A	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1814GR-9JG-E1-A	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1815GR-9JG-E1-A	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1857GR-9JG-E1-A	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1870BGR-9JG-E1-AT	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1873GR-9JG-E1-A	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1890GR-9JG-E1-A	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1902TE-T1-A	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1902TE-T1-AT	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1911ATE-T1-A	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1912TE(0)-T1-AT	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1912TE-T1-A	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1917TE-T1-AT	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1919TE-T1-A	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1919TE-T1-AT	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1930TE-T1-AT	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1950TE-T1-A	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1950TE-T1-AT	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1951TE-T1-A	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1951TE-T1-AT	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1952TE-T1-AT	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1970TE-T1-A	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1970TE-T1-AT	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1981TE-T1-A	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA1981TE-T1-AT	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA2350T1P-E4-A	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA2351T1P-E4-A	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA2352T1P-E4-A	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA2372T1P-E4-A	Wafer Fabrication Site Change from Shiga to Naka

UPA2375T1P-E1-A	Wafer Fabrication Site Change from Shiga to Naka
UPA2378T1P-E1-A	Wafer Fabrication Site Change from Shiga to Naka
UPA2385T1P-E1-A	Wafer Fabrication Site Change from Shiga to Naka
UPA2670T1R-E2-AX	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA2672T1R-E2-AX	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA2706GR-E1-A	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA2714GR(0)-E1-A	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA2735GR-E1-AT	Wafer Fabrication Site Change from Shiga to Naka
UPA2736GR-E1-AT	Wafer Fabrication Site Change from Shiga to Naka
UPA2738GR-E1-AT	Wafer Fabrication Site Change from Shiga to Naka
UPA2752GR(1)-E1-A	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA2752GR-E1-A	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA2752GR-E1-AT	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA2766T1A-E2-AY	Wafer Fabrication Site Change from Shiga to Naka
UPA2782GR-E1-A	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA2782GR-E1-AT	Wafer Fabrication Site Change from Shiga to Kawashiri
UPA2812T1L-E1-AT	Wafer Fabrication Site Change from Shiga to Naka
UPA2813T1L-E1-AT	Wafer Fabrication Site Change from Shiga to Naka
UPA502T(0)-T1-A	Wafer Fabrication Site Change from Tsuruoka to Kawashiri
UPA502T-T1-A	Wafer Fabrication Site Change from Tsuruoka to Kawashiri
UPA502T-T2-A	Wafer Fabrication Site Change from Tsuruoka to Kawashiri
UPC1093T-E1-AZ	Wafer Fabrication Site Change from Tsuruoka to Naka
UPD166023T1J-E1-AY#YE	Wafer Fabrication Site Change from SSA to Shiga
UPD166026T1K-E1-AY#YE	Wafer Fabrication Site Change from SSA to Shiga
UPA2379T1P-E1-A	Wafer Fabrication Site Change from Shiga to Naka
RBK01P01GQT-0000#GCH	Wafer Fabrication Site Change from Shiga to Naka
HA13721FPK-E	Wafer Fabrication Site Change from Takasaki to Naka